

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Dao Min Zhou, et al	)	Art Unit No.: 3762
	)	
Application No: 10/655,772	)	Examiner: Kahelin, Michael W.
	)	
Filed: September 5, 2003	)	Re: <b>RESPONSE TO</b>
	)	<b>RESTRICTION REQUIREMENT</b>
	)	
For: "Adherent Metal Oxide ..."	)	Our Ref: S232-USA
	)	
	)	
	)	Date: November 28, 2007

**RESPONSE TO RESTRICTION REQUIREMENT**

Dear Examiner:

This paper is filed in response to the restriction requirement set forth in the Office Action dated October 26, 2007 a reply to which was initially due by November 26, 2007. Please consider the following remarks with respect to the subject application. All remarks herein are made without prejudice.

**Remarks** begin on page 2 of this paper.

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